## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Hongqin Shi, et al.

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Title:

METHODS AND APPARATUS OF ETCH PROCESS CONTROL IN

FABRICATIONS OF MICROSTRUCTURES

Grp./A.U.:

1765

Examiner:

Lan Vinh

Confirmation No.: 8251

Commissioner for Patents

P.O. Box 1450 Alexandria, VA 22313-1450

Debbie Sams (Printed or typed name of person signing the certificate)

with United States Patent and trademark Office on:

I hereby certify that this correspondence is being electronically filed

/Debbie Sams/

October 8, 2007

(Signature of the person signing the certificate)

Sir:

## AMENDMENT UNDER 37 C.F.R. § 1.111

The Applicants have carefully considered this application in connection with the Examiner's Action electronically delivered July 6, 2007, and respectfully request reconsideration of this application in view of the following amendment and remarks.